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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re application of: Dalton et al.

Attorney Docket No.: NOVLP082/002893

Application No.: New

Examiner: Not Yet Assigned

Filed: Herewith

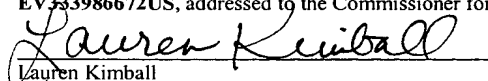
Group: Unknown

Title: USE OF METALLOCENES TO INHIBIT  
COPPER OXIDATION DURING  
SEMICONDUCTOR PROCESSING

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**CERTIFICATE OF EXPRESS MAILING**

I hereby certify that this paper and the documents and/or fees referred to as attached therein are being deposited with the United States Postal Service on February 03, 2004 in an envelope as "Express Mail Post Office to Addressee" service under 37 CFR §1.10, Mailing Label Number EV333986672US, addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

  
Lauren Kimball

**PRELIMINARY AMENDMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Before examination of the subject application, please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which being on page 2 of this papers.

**Remarks/Arguments** begin on page 5 of this paper.